


Search Notes 	Application/Control No. 10677309	Applicant(s)/Patent Under Reexamination SUZUKI ET AL.
	Examiner Arancibia, Maureen G	Art Unit 1792

SEARCHED			
Class	Subclass	Date	Examiner
UPDATED	SEARCH	10/28/07	MGA
UPDATED	SEARCH	3/25/08	MGA
UPDATED	SEARCH	10/9/08	MGA

SEARCH NOTES			
Search Notes		Date	Examiner
UPDATED SEARCH		10/28/07	MGA
UPDATED SEARCH		3/25/08	MGA
UPDATED SEARCH		10/9/08	MGA
Google Patents search: "silicon wafer etch then clean with mixture of hydrofluoric acid and hydrogen peroxide"		10/9/08	MGA

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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